



Application Serial No. 10/643,680
Filing Date August 18, 2003
Confirmation No. 4607
Inventor..... Brenda D. Kraus et al.
Assignee Micron Technology, Inc.
Group Art Unit 1762
Examiner Brian K. Talbot
Attorney's Docket No. MI22-2310
Customer No. 021567
Title: Atomic Layer Deposition Methods of Forming Conductive Metal Nitride
Comprising Layers

RESPONSE TO OCTOBER 12, 2006 OFFICE ACTION

To: Mail Stop Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

VIA EXPRESS MAIL

From: Mark Matkin (Tel. 509-624-4276; Fax 509-838-3424)
Wells St. John P.S.
601 West First Avenue, Suite 1300
Spokane, WA 99201-3828

Responsive to the Office Action dated October 12, 2006, Applicant
amends and remarks as follows:

AMENDMENTS

01/16/2007 AWONDAF1 00000115 10643680

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